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Title of Invention

SPUTTERING APPARATUS AND MANUFACTURING METHOD OF
METAL LAYER/METAL COMPOUND LAYER BY USING THEREOF

Application Number :

Date :

First Named Applicant: Mr. Yu-Cheng Liu

Confirmation Number:

Attorney Docket Number: 10683-US-PA-1

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| Submitted By: | Elec. Sign. | Sign. Capacity |
|--|---------------|----------------|
| Dr. Belinda Lee Registered Number: 46,863 | /Belinda Lee/ | Agent |

| Documents being submitted: | Files |
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| us-request | 10683-D-usrequ.xml us-request.dtd us-request.xsl |
| us-fee-sheet | 10683-D-usfees.xml us-fee-sheet.xsl us-fee-sheet.dtd |
| application-body | 10683Dusf.xml application-body.dtd Image1.tif isoamsa.ent isoamsb.ent isoamsc.ent isoamsn.ent isoamso.ent isoamsr.ent isobox.ent isocyr1.ent isocyr2.ent isodia.ent isogr1.ent isogr2.ent isogr3.ent isogr4.ent isolat1.ent isolat2.ent isomfrk.ent isomopf.ent isomscr.ent isonum.ent isopub.ent isotech.ent mathml2.dtd mathml2-qname-1.mod mmlalias.ent mmlextra.ent soextblx.dtd us-application-body.xsl wipo.ent |
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